#### Receipt date: 06/25/2010

## 10523373heeGAU31711

Substitute for form 1449B/PTO	ATTORNEY DOCKET NO.		APPLICATION NO.	
SUPPLEMENTAL INFORMATION	3194.1026-006		10/523,371	
DISCLOSURE STATEMENT IN AN APPLICATION	FIRST NAMED INVENTOR		FILING DATE	
	Jeffrey J. Spiegelman		June 21, 2005	
LISTING OF REFERENCES	EXAMINER	CONFIRMATION NO.		GROUP
June 25, 2010	Carrillo, Bibi Sharidan	3702		1792
(Use several sheets if necessary)				1711

	U.S. PATENT DOCUMENTS						
Examiner's Initials	No.	DOCUMENT NUMBER Number-Kind Code (if known)	ISSUE DATE / PUBLICATION DATE MM-DD-YYYY	NAME OF PATENTEE OR APPLICANT OF CITED DOCUMENT			
	A52	6,116,858	09-12-2000	Narabayashi			
	A53	2005/0087133 A1	04-28-2005	Shindo, <i>et al.</i>			
	A54	2005/0205114 A1	09-22-2005	Alvarez, Jr., <i>et al.</i>			

We are not listing separately any prior U.S. Patent Office communications regarding the cited application(s) because the Examiner has access to any such actions through PAIR.

EXAMINER (2) 11 0 (1)	DATE CONSIDERED	
/Sharidan Carrillo/	07/10/2010	
994634 1 ALL REFERENCES CONSID	ERED EXCEPT WHERE LINED THROUGH	. /SC/

### Receipt date: 06/25/2010

## 10523371 \_\_\_\_GAU; 1711

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June 25, 2010	Carrillo, Bibi Sharidan	3702		<del>1792 -</del> 1711
(Use several sheets if necessary)				

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	B21	JP 2002-217157 (Å) (English Abstract)	08-02-2002	Tokyo Electron Ltd.		
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EXAMINER /Sharidan Carrillo/ DATE CONSIDERED

07/10/2010

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## Receipt date: 06/25/2010

# 10523371 6 GAU: 1711

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EXAMINER /Sharidan Carrillo/		DATE CONSIDERED	
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